

00684.002728



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Tomoharu HASE) : Examiner: H. Nguyen
Application No.: 09/145,982) : Group Art Unit: 2851
Filed: September 3, 1998) :
For: EXPOSURE APPARATUS AND DEVICE) July 28, 2003
MANUFACTURING METHOD)
INCLUDING GAS PURGING OF A)
SPACE CONTAINING OPTICAL)
COMPONENTS)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION UNDER 37 C.F.R. § 1.136(a)

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated January 28, 2003, for one additional month from June 28, 2003, up to and including July 28, 2003.

Submitted herewith is a check for \$520.00 to cover the fee for the extension under 37 C.F.R. § 1.17. A petition for a two month extension of time and requisite fee of \$410.00 were timely filed on Monday, June 30, 2003. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205. A duplicate of this petition is enclosed.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
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